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AMENDMENT TRANSMITTAL LETTER			Docket No. H6808.0041/P041	
Application No. 10/780,752	Filing Date February 19, 2004	Examiner G. M. Desire	Art Unit 2625	
Applicant(s): Michio Nakano et al.				
Invention: IMAGE PROCESSING UNIT FOR WAFER INSPECTION TOOL				
TO THE COMMISSIONER FOR PATENTS				
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.				
CLAIMS AS AMENDED				
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate
Total Claims	8	- 20 =		x
Independent Claims	2	- 6 =		x
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>				
Other fee (please specify): Extension for response within third month				1,050.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:				1,050.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity				
<input type="checkbox"/> No additional fee is required for this amendment.				
<input type="checkbox"/> Please charge Deposit Account No. <u>04-1073</u> in the amount of \$ _____ A duplicate copy of this sheet is enclosed.				
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.				
<input checked="" type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.				
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>04-1073</u> as described below. A duplicate copy of this sheet is enclosed.				
<input checked="" type="checkbox"/> Credit any overpayment.				
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.				
<div style="text-align: right;"><i>[Handwritten signature]</i> #41,198</div> <div>Mark J. Thronson Attorney/Agent Reg. No.: 33,082</div>			Dated: <u>January 11, 2008</u>	
DICKSTEIN SHAPIRO LLP 1825 Eye Street, NW Washington, DC 20006-5403 (202) 420-4742				



Docket No.: H6808.0041/P041
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Michio Nakano et al.

Application No.: 10/780,752

Confirmation No.: 1776

Filed: February 19, 2004

Art Unit: 2625

For: IMAGE PROCESSING UNIT FOR WAFER
INSPECTION TOOL

Examiner: G. M. Desire

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated July 13, 2007, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.